

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: November 25, 2008

Haight et al.

Group Art Unit: 3742

Serial No.: 09/933,461

Examiner: Geoffrey S. Evans

Filed: August 20, 2001

Docket No.: YOR919980510US2

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL RESPONSE TO OFFICE ACTION DATED 05/07/2008

Amendments to the claims begin on 2 page of this paper.

Remarks begin on 20 page of this paper.